Application Number:	10	10804053						
Filing Date:	19-	19-Mar-2004						
Title of Invention:		FILM FORMATION METHOD AND MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE						
First Named Inventor/Applicant Name:	Mit	Mitsuhiro Ichijo						
Filer:	Jef	Jeffrey Costellia/Carmela Beverly						
Attorney Docket Number:	74	740756-2718						
Filed as Large Entity								
Utility under 35 USC 111(a) Filing Fees	;							
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)			
Basic Filing:					1			
Pages:								
Claims:								
Miscellaneous-Filing:								
Petition:								
Patent-Appeals-and-Interference:								
Post-Allowance-and-Post-Issuance:								

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Printed copy of patent - no color	8001	5	3	15
	Tot	1755		